Title: Substrate Processing Metho Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

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FIG.IA PRIOR ART

FIG.IB PRIOR ART

FIG.IC PRIOR ART

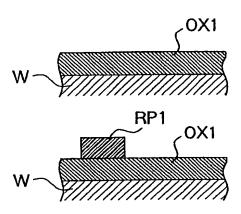
FIG.ID PRIOR ART

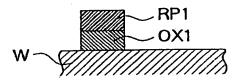
FIG.IE PRIOR ART

FIG.IF PRIOR ART

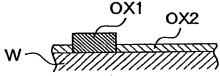
FIG.IG PRIOR ART

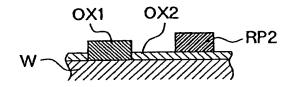
FIG.IH PRIOR ART

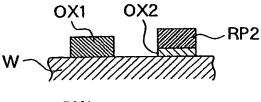


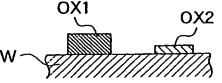








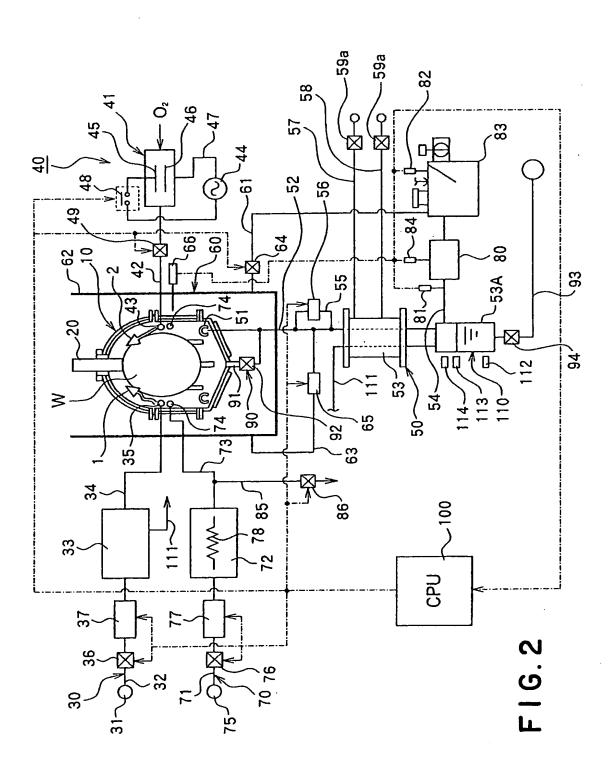




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Title: Substrate Processing Mond and Substrate..
Inventor: Takayuki TOSHII
Application No.: Not yet assigned
Docket No.: 199372003500

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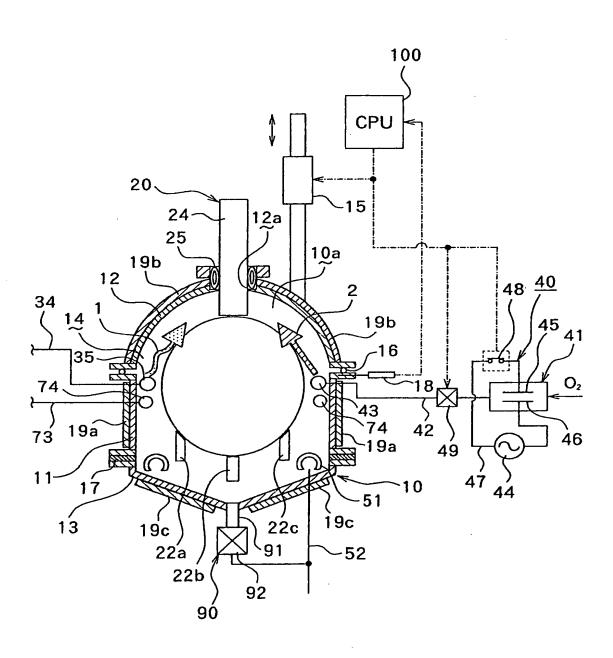


FIG. 3

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSI Application No.: Not yet assigned Docket No.: 199372003500

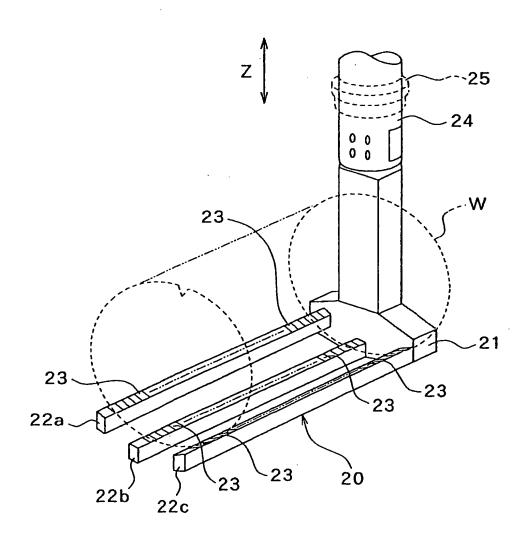


FIG. 4

Title: Substrate Processing Ma Inventor: Takayuki TOSHIM and Substrate..

Application No.: Not yet assigned Docket No.: 199372003500

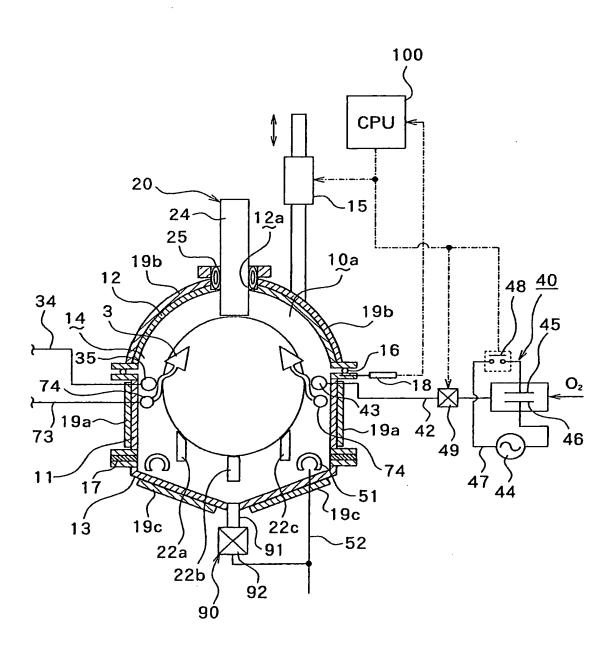


FIG. 5

Title: Substrate Processing Method Substrate... Inventor: Takayuki TOSHIMA

Application No.: Not yet assigned Docket No.: 199372003500

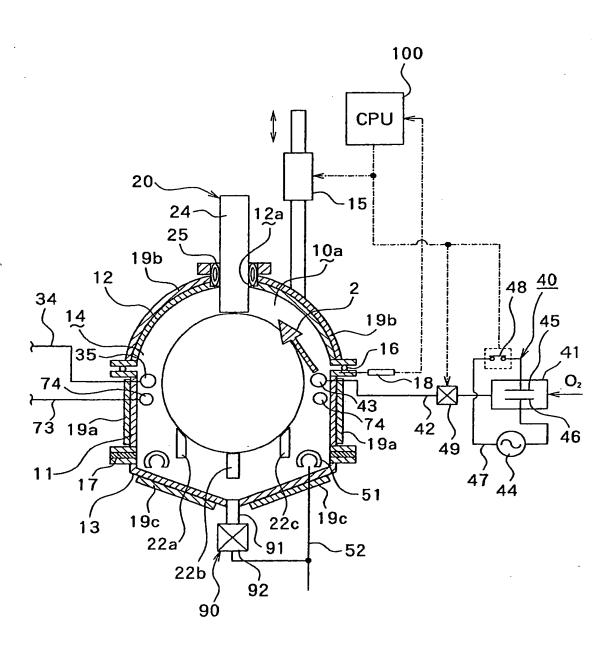
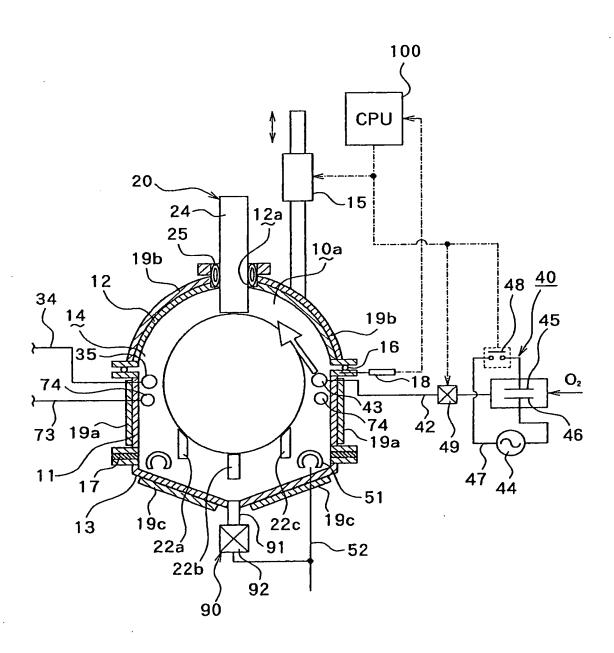


FIG. 6

Title: Substrate Processing Management and Substrate...

Application No.: Not yet assigned Docket No.: 199372003500



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Title: Substrate Processing Method Substrate... Inventor: Takayuki TOSHIMA

Application No.: Not yet assigned

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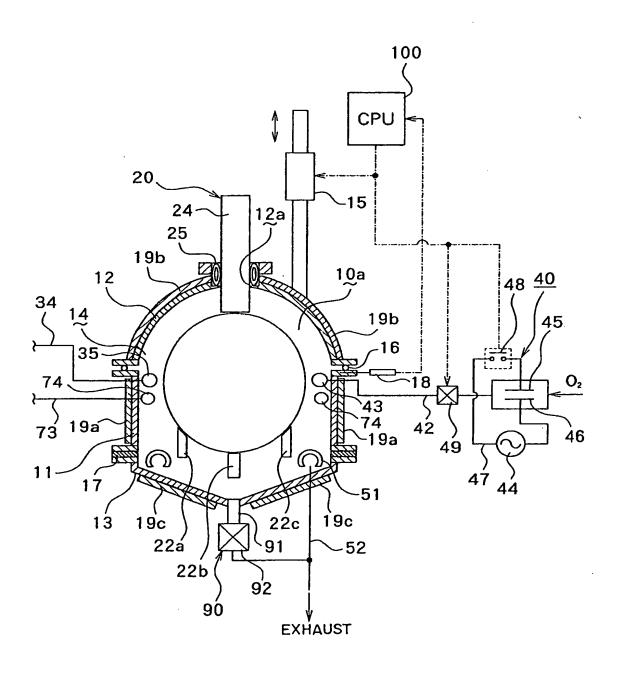
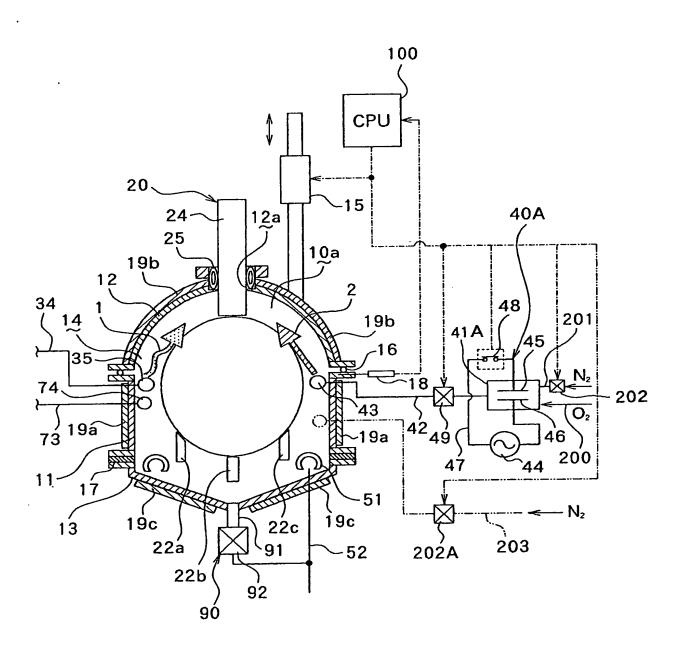


FIG. 8



Title: Substrate Processing Method and

Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500 ate..



F1G. 9

Title: Substrate Processing Meth Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

